



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

April 4, 2026	
IGI Report Number	LG787646525
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE CUSHION MODIFIED BRILLIANT
Measurements	7.95 X 7.77 X 5.31 MM

GRADING RESULTS

Carat Weight	2.51 CARATS
Color Grade	F
Clarity Grade	VS 2

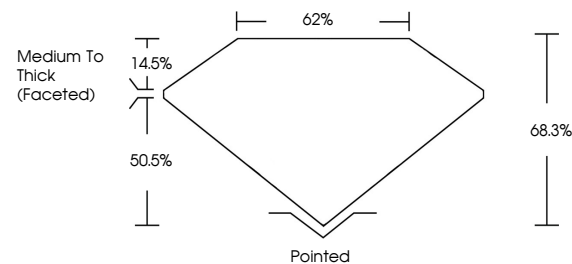
ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG787646525

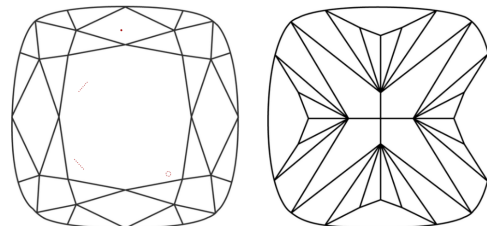
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

LG787646525
Report verification at igi.org

PROPORTIONS

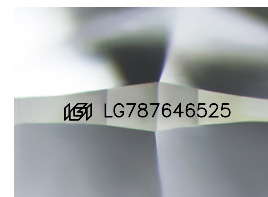


CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

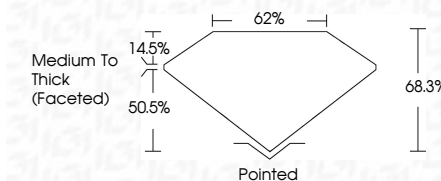
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

LABORATORY GROWN DIAMOND REPORT



April 4, 2020	
IGI Report Number	LG787646525
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	SQUARE CUSHION MODIFIED BRILLIANT
Measurements	7.95 X 7.77 X 5.31 MM
GRADING RESULTS	
Carat Weight	2.51 CARATS
Color Grade	F
Clarity Grade	VS 2



ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG787646525
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa	



© IGI 2020, International Gemological Institute

FD - 10 20



THIS DOCUMENT WAS PRODUCED WITH THE FOLLOWING SECURITY MEASURES: SPECIAL DOCUMENT PAPER, INK SCREENS, WATERMARK, BACKGROUND DESIGNS, HOLOGRAM AND OTHER SECURITY FEATURES NOT LISTED AND DO EXCEED DOCUMENT SECURITY INDUSTRY GUIDELINE

www.igi.org

April 4, 2026
G1 Report No
SQUARE CUSHI
9.95 X 7.77 X 5
Carat Weight
Color Grade
Clarity Grade
Depth
Table
Girdle
Culet
Polish
Symmetry
Fluorescence
certification(s)

Comments:
This Laboratory Grown Diamond was
created by Chemical Vapor Deposition
(CVD) growth process.